

503.34897CC3

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

MABUCHI et al

RECEIVED

Serial No.:

09/838,139

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Filed:

April 20, 2001

**TECHNOLOGY CENTER R3700** 

For:

Absorption Refrigerator and Production Method Thereof

Group:

3744

Examiner:

Shulman, M.

7-28-03

## <u>AMENDMENT</u>

Assistant Commissioner For Patents Washington, D.C. 20231

February 25, 2003

Sir:

This is in response to the Office Action mailed November 25, 2002, in connection with the above-identified application.

## IN THE CLAIMS:

Please amend the claims to read as follows:

suhc'/

5 (Amended) A production method of an absorption refrigerator using a refrigerant and its absorption solution, comprising:

oxidizing a surface of at least a part of a heat exchanger and high temperature regenerator at a temperature of 200-800°C in atmosphere; and

adjusting the heating temperature and heating retaining time so that a value of parameter (P) obtained according to an equation  $P=T(5 + \log t)$ , wherein T is a heating temperature (°K) and t is a heating retaining time (minute), is  $3.5-6.0 \times 10^3$ .